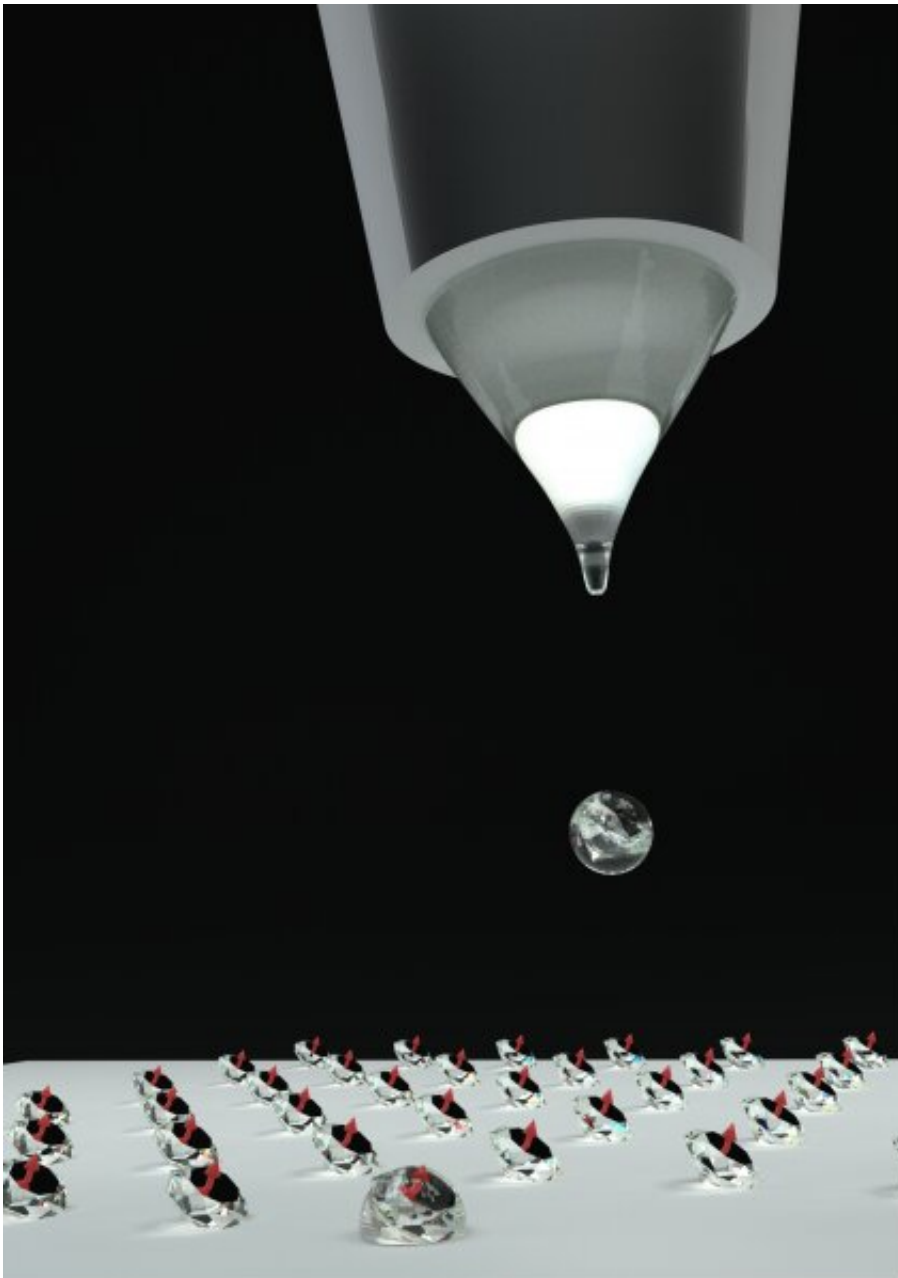


Direct printing of nanodiamonds at the quantum level

April 27 2022



Nano-precision printing of NV-center nanodiamonds using the new technology.
Credit: The University of Hong Kong

Diamond nanocrystals, namely nanodiamonds, which host point defects such as nitrogen-vacancy (NV) centers, are a promising quantum material.

A central requirement to realize practical applications is the placement of individual NV centers at will on integrated circuits. This is critical for implementing [quantum technologies](#), leading to a number of exciting opportunities and emerging fields such as quantum computers, [quantum communications](#), and quantum metrology.

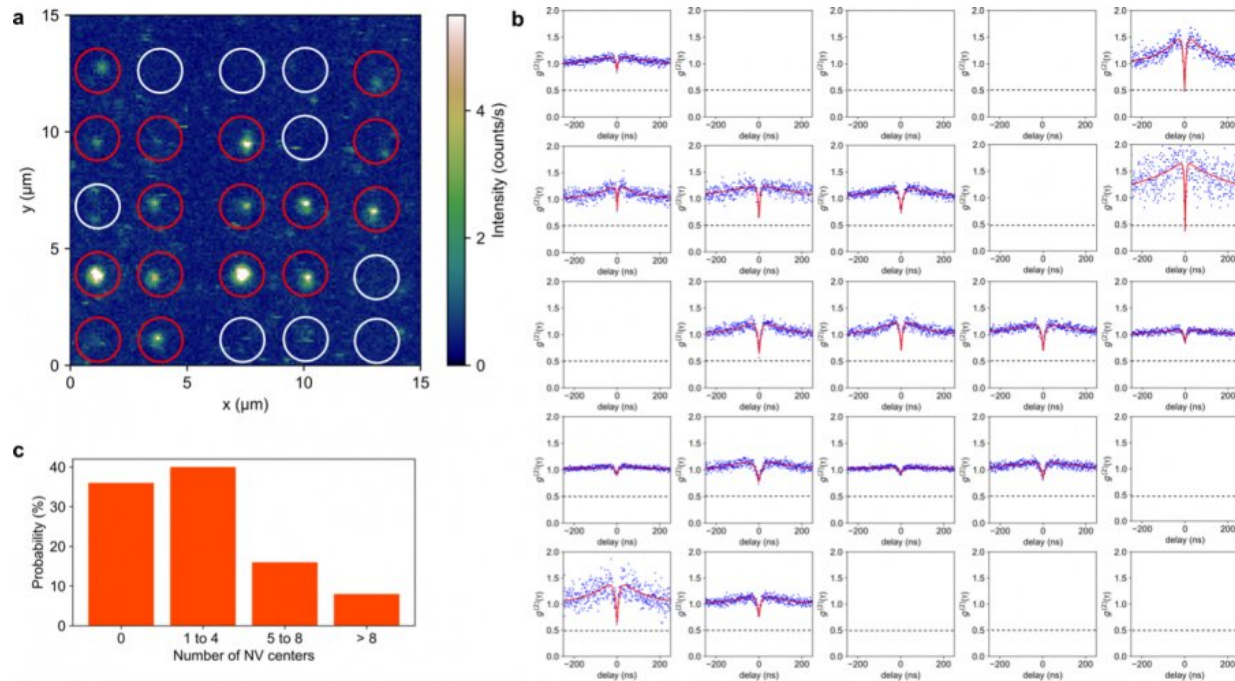
However, a flexible, universal route is still needed for achieving nanoscale accuracy, scalability, cost-effectiveness and efficient coupling with a wide range of nanophotonic circuitries.

Several methods, such as the sophisticated "pick-and-place" nanomanipulation approach, have been devised to position the nanodiamonds with NV centers on various substrates and circuits. However, this prerequisite continues to suffer from coarse positioning accuracy, low throughput, and process complexity.

The team led by Dr. Ji Tae Kim from the Department of Mechanical Engineering and Dr. Zhiqin Chu from the Electrical and Electronic Engineering of the University of Hong Kong (HKU) has developed a nano-precision printing method for nitrogen-vacancy (NV) centers in diamond at the quantum level, meeting the technological requirements.

This novel approach is practical and cost-effective, paving the way for manufacturing of quantum information processing device, [quantum](#)

[computing](#) and biosensing devices.



Printed NV centers at the quantum-level. a) Confocal fluorescence image. b) Second-order correlation functions $g^{(2)}(\tau)$ of corresponding fluorescence spots. c) Number distribution histogram of printed NV centers per spot. Credit: The University of Hong Kong

The research achievement has been published in *Advanced Science* in an article titled "On-Demand, Direct Printing of Nanodiamonds at the Quantum Level."

The NV center is a point-defect in the diamond lattice and is the most common defect in nanodiamonds. It has emerged as a powerhouse for [quantum systems](#) due to their robust quantum states even at [room temperature](#) while other quantum systems such as superconducting

quantum interference device can only operate at [cryogenic temperatures](#), i.e., from -150 degrees C (-238 degrees F) to absolute zero (-273 degrees C or -460 degrees F).

Specifically, this atom-like, solid-state device, with its optically addressable spin-degrees-of-freedom, provides the key functionalities for serving as the quantum bit and/or quantum sensor in solid-state quantum processors.

'Diamond is the hardest material, so it is difficult to craft'

The researchers have developed an innovative way to tackle this issue. They have utilized electrical dispensing of nanodiamond-laden liquid droplets with sub-attoliter (10^{-18} liter) volume for placing NV-centers directly on universal substrates.

"To the best of our knowledge, the developed technique, for the first time, shows sub-wavelength positional accuracy, single-defect-level quantity control, and freeform patterning capabilities, meeting the technological requirements which marks a significant breakthrough in quantum device manufacturing," said Dr. Chu Zhiqin.

More information: Zhaoyi Xu et al, On-Demand, Direct Printing of Nanodiamonds at the Quantum Level, *Advanced Science* (2021). [DOI: 10.1002/advs.202103598](https://doi.org/10.1002/advs.202103598)

Provided by The University of Hong Kong

Citation: Direct printing of nanodiamonds at the quantum level (2022, April 27) retrieved 16

August 2024 from <https://phys.org/news/2022-04-nanodiamonds-quantum.html>

This document is subject to copyright. Apart from any fair dealing for the purpose of private study or research, no part may be reproduced without the written permission. The content is provided for information purposes only.